



AF/ 2675

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Norihiro Imai, et al.

Serial No.: 10/062,279

Filed: January 30, 2002

For: BACK LIGHT CONTROL  
METHOD AND DISPLAY  
DEVICE

Group Art Unit: 2675

Examiner: U.O. Anyaso

Attorney Docket: OMRN P015

**CERTIFICATE OF MAILING**

Date of Deposit: September 28, 2004

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**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. §1.56 AND §§1.97-1.98**

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Sir:

The following Form 1449 and copies of documents listed thereon are being  
filed herewith as a Disclosure Statement. Consideration of each of these documents by the  
Patent Examiner, and the making of each of them of record in the file of this application, are  
respectfully requested.

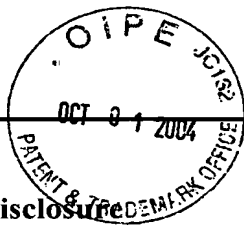
Each item of information contained in this information disclosure statement  
was cited in a communication from a foreign patent office in a counterpart foreign  
application not more than three months prior to the filing of this statement.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Keiichi Nishimura', written over the printed name.

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September 28, 2004  
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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No. <b>OMRNP015</b>	Application No.: <b>10/062,279</b>
	Applicant: <b>Norihiro Imai, et al.</b>	Group <b>2675</b>
	Filing Date <b>January 30, 2002</b>	RECEIVED <b>OCT 06 2004</b> Technology Center 2000

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A						
	B						
	C						
	D						

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	E	11-126118	11/05/99	Japan			X	
	F	03-168616	22/07/91	Japan			X	
	G	2000-276248	06/10/00	Japan			X	
	H	05-224713	03/09/93	Japan			X	
	I	05-289707	05/11/93	Japan			X	
	J	06-075610	18/03/94	Japan			X	
	K	2000-242315	08/09/00	Japan			X	

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	L	
	M	
	N	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.